## Imperial College London



# THIN FILM DEVICE MATERIALS PLATFORM

The new Royce Thin Film Device Materials Platform at Imperial College London provides a platform for the construction of bespoke thin film devices, from deposition and patterning to electrical and physical characterisation, embracing the entire research and development lifecycle.

The facility was originally founded by Prof Neil Alford and Dr Peter Petrov in 2001 and is open to users from both academia and industry. It is located on the 8th floor of the new, state-of-the-art Sir Michael Uren Hub based at Imperial's White City campus.

### CE-BEAM LITHOGRAPHY SUITE

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Raith E-Beam Lithographer

#### CLEANROOM - YELLOW ROOM PHOTOLITHOGRAPHY SUITE

Patterning

- Karl Suss Mask Aligner
- OAI Mask Aligner
- Spin Coater

#### CLEANROOM

#### Deposition, Patterning, Characterisation

- Combined Magnetron Sputtering (HIPIMS) and E-Beam Deposition
- Wide Beam Ion Milling
- Inducitvely Coupled Palsma -Reactive Ion Etching
- Surface Profiler
- Thin Film Analyser

#### **DEPOSITION LAB**

#### Deposition, Patterning, Characterisation

- HEX-L Sputtering System
- HEX Sputtering System
- Combined Physical and Chemical Vapour Deposition
- Reactive Ion Etching
- Dicing Saw
- Surface Profiler



#### **ELECTRONICS LAB**

#### Characterisation

- Room Temperature Probe Station
- Cryo Probe Station
- RF LCR Meter
- Semiconductor Device Analyser
- Vector Network Analyser
- Ferroelectric Test System
- Current/Voltage Source and Measurement
- Thermal Analyser

#### **PREPARATION LAB**

#### Preparation

- 1600°C Muffle Furnace
- 1200°C Tube Furnace
- 250°C Oven
- Planetary Ball Mill
- Target Press
- Analytical Balance

#### **CHARACTERISATION LAB**

#### Characterisation

- MultiCore High-Performance X-ray Diffractometer
- Scanning Electron Microscope
- Dual beam FIB with Cyro-Stage
  Electron Microscope

#### LASER LAB

#### Characterisation, Deposition

- Raman Spectrometer
- Atomic Force Microscope
- Pulsed Laser Deposition 4 Chambers



To enquire, please contact

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